Supporting information:

## Corrosion stability of NASICON-based membranes against aqueous solutions: case study for sodium iodine batteries



Figure S1: XRD patterns of  $Na_{3.4}Sc_{0.4}Zr_{1.6}Si_2PO_{12}$  (NSZSiP3.4) as sintered (black) and after 3 days of exposure to 3M NaI<sub>3</sub> solution at 100 °C (red).



Figure S2: XRD patterns of  $Na_{3.1}Mg_{0.05}Zr_{1.95}Si_2PO_{12}$  (NMZSiP3.1) as sintered (black), after 3 days (red) and after 5 months (light green) of exposure to 3M NaI<sub>3</sub> solution at 100 °C.



Figure S3: XRD patterns of  $Na_{3.2}Hf_2Si_{2.2}P_{0.8}O_{12}$  (NHSiP3.2) as sintered (black), after 3 days (red) and after 5 months (light green) of exposure to 3M NaI<sub>3</sub> solution at 100 °C.



Figure S4: a) Lattice parameters of the protonated NZSiP3.4 as a function of exposure time to 3M NaI<sub>3</sub> at 100 °C. b) Lattice parameters of the protonated phase in the NZSiP3.4, NMZSiP3.1 and NHSiP3.2 in comparison to a non-protonated NaSICON material.



Figure S5: Lattice parameters of the protonated phase in the NZSiP3.4, NMZSiP3.1 and NHSiP3.2 as a function of exposure time to 3M NaI<sub>3</sub> at 100 °C. (Lines are guide to the eye only.)



Figure S6: Hydrogen content in the NZSiP3.4 samples after exposure to 3M NaI<sub>3</sub> at 100  $^{\circ}$ C for 3 days, 10 days and 5 months.

Table S1: Summary of the phase compositions of the investigated powders as-sintered and after exposure to the respective solutions after Rietveld analysis with the ICSD data sets 38096 (NaSICON low), 202279 (basis for protonated NaSICON-Model), 81696 (NaSICON high), 18190 (ZrO<sub>2</sub>) and 27313 (HfO<sub>2</sub>) as reference.

sample name	phase		space	( 8 )	1 (8)	( 8 )	1 (0)	wt.%
	no.	Phase Name	group	a (A)	b (A)	c (A)	beta(°)	Rietveld
NZSiP3.4 as-sintered	1	NaSICON low	C 1 2/c 1	15.738	9.099	9.208	124.273	100
NZSiD3 4 offer 7 days in	1	NaSICON low	$C = 1 \frac{2}{c} 1$	15 738	9 099	9 206	124 298	98
sat Nal	2	protonated NaSICON	R-3c	8 013	-	24 552	-	< 3
Sat. Indi	2		11-50	0.915	-	24.002	-	< 0
NZSiP3.4 after 3 days in	1	protonated NaSICON	R-3c	8.928	-	24.515	-	5
3M Nal sol.	2	NaSICON low	C 1 2/c 1	15.74	9.1	9.204	124.312	95
NZSiP3 4 after 3 days in	1	NaSICON low	C 1 2/c 1	15.735	9.099	9.2	124.297	90
3M Nal sol. at pH=1.29	2	protonated NaSICON	R-3c	8.931	-	24.533	-	10
·	-	p		0.001				
NZSiP3.4 after 3 days in	1	NaSICON low	C 1 2/c 1	15.736	9.098	9.198	124.304	82
3M Nal3	2	protonated NaSICON	R-3c	8.934	-	24.526	-	18
	4		D 0-	0.005		04 540		00
NZSiP3.4 after 10 days	1			8.935	-	24.542	-	22
IN 3M Nai3	2	NaSICON low	C 1 2/C 1	15.73	9.096	9.2	124.276	78
NZSiP3.4 after 5 months								
in 3M Nal3	1	protonated NaSICON	R-3c	8.914	-	24.645	-	100
NZSiD2 / after 5 months								
in 3M Nal3 + 14 days in	, 1	protonated NaSICON	R-3c	8.913	-	24.645	-	100
saturated Nal sol.		•						
NSo7SiD2 4 op ointered	1	NaSICON low	C 1 2/c 1	15.716	9.077	9.185	124.483	99
NSCZSIP3.4 as-sintered	2	Zirconium-oxide	P 1 21/c 1	5.144	5.21	5.311	99.22	< 3
NScZSiP3.4 after 3 davs	1	NaSICON low	C 1 2/c 1	15.672	9.06	9.193	124.205	74
in 3M Nal3	2		R-3c	8.924	-	24.409	-	26
	3	Zirconium-oxide	P 1 21/c 1	5.14422	5.21	5.311	99.22	< 3
NM79iD2 1 as sintered	1	NaSICON low	C 1 2/c 1	15.649	9.053	9.221	123.728	98
INIVIZOIPO. I AS-SINIEREO	2	Zirconium-oxide	P 1 21/c 1	5.144	5.21	5.311	99.22	< 3
	4	NEOLOONU	040/ 1	45.000	0.050	0.00	400.047	
NMZSiP3.1 after 3 days	1			15.639	9.052	9.23	123.647	<i>(</i> 5
in 3M Nal3	2		K-30	8.906	-	24.533	-	23
	3	Zirconium-oxide	P 1 21/C 1	5.144	5.21	5.311	99.22	< 3
NMZSiP3.1 after 5	1	protonated NaSICON	R-3c	8.881	-	24.648	-	98

months in 3M Nal3	2	Zirconium-oxide	P 1 21/c 1	5.144	5.21	5.311	99.22	< 3
- NHSiP3.2 as-sintered	1	NaSICON low	C 1 2/c 1	15.595	9.019	9.219	123.683	100
NHZSiP3.2 after 3 days	1	NaSICON low	C 1 2/c 1	15.57	9.01	9.217	123.57	75
in 3M Nal3	2	protonated NaSICON	R-3c	8.911	-	24.376	-	25
	1	NaSICON low	C 1 2/c 1	15.466	9.018	9.262	123.113	13
NHZSiP3.2 after 5	2	protonated NaSICON	R-3c	8.852		24.548		86
months in 314 Nai3	3	Hafnium-oxide	P 1 21/c 1	5.044	5.091	5.308	98.713	< 3
-								
N7SiP3 () as sintered	1	Zirconium-oxide	P 1 21/c 1	5.144	5.21	5.311	99.22	3
NZOF 5.0 as-sintered	2	NaSICON low	C 1 2/c 1	15.634	9.044	9.224	123.649	97
NZSID2 0 offer 10 days	1	NaSICON low	C 1 2/c 1	15.601	9.037	9.239	123.502	48
in 3M Nal3	2	Zirconium-oxide	P 1 21/c 1	5.144	5.21	5.311	99.22	4
	3	protonated NaSICON	R-3c	8.903	-	24.527	-	49
-	1	Ziroonium ovido	D 1 21/2 1	5 1 1 1	5 01	5 211	00.22	4
sintered	2	NaSICON low	C 1 2/c 1	5.144 15.679	9.072	9.231	99.22 123.894	4 96
	1	Zirconium-oxide	P 1 21/c 1	5.144	5.21	5.311	99.22	4
NZSiP3.0sub after 10	2	NaSICON low	C 1 2/c 1	15.661	9.071	9.224	123.755	89
days in 3M Nai3	3	protonated NaSICON	R-3c	8.913	-	24.589	-	8
- NZSiP1.0 as-sintered	1	NaSICON high	R-3c	8.802	-	22.868	-	100
NZSiP1.0 after 5 months in 3M Nal3	1	protonated NaSICON	R-3c	8.922	-	24.648	_	5
	2	NaSICON high	R-3c	8.808	-	22.775	-	95



Figure S7: EDS images of sintered NaSICON powder after 3 days of exposure to  $3M NaI_3$  solution, measured on Ir-waver.

EDS Layered Image 1

O K seriesNa K seriesSi K seriesImage: Si K series

Figure S8: EDS images of sintered NaSICON powder after 10 days of exposure to  $3M \text{ NaI}_3$  solution.



Figure S9: EIS spectra of dense  $Na_{3.4}Sc_{0.4}Zr_{1.6}Si_2PO_{12}$  before and after exposure to 3M  $NaI_3$  as well as after surface polishing of the etched pellet.



Figure S10: EIS spectra of dense  $Na_{3.4}Al_{0.4}Y_{0.2}Zr_{1.6}Si_2PO_{12}$  before and after exposure to 3M  $NaI_3$  as well as after surface polishing of the etched pellet.



Figure S11: EIS spectra of dense  $Na_{3,4}Zr_{2,4}Si_2P_{0.6}O_{12}$  before and after exposure to 3M  $NaI_3$  as well as after surface polishing of the etched pellet.